## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)
Yoshihisa NAGANO, et al.	)
Application No. 10/829,476	) Confirmation No. 5876
Filed: April 22, 2004	)
For: SEMICONDUCTOR DEVICE AN METHOD OF FABRICATING THE SAME	· · · · · · · · · · · · · · · · · · ·

## **STATUS INQUIRY**

Commissioner for Patents Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

Please advise, in writing, as to the current status of the above-identified application.

Respectfully submitted,

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